Search Notes



Application/Control No.

10667368

Applicant(s)/Patent Under Reexamination NOGUCHI, TAKAFUMI

Examiner

Examiner Choi, Jacob Y Art Unit 2885

	SEARCHED				
Class	Subclass	Date	E		
362	459, 545, 6, 8, 446, 470, 505, 506, 259, 231	10/20/2005	JC		

SEARCH NOTES					
Search Notes	Date	Examiner			
Class/Subclass & Text Search Conducted by Examiner (including class 359)	10/20/2005	JC			
Updated Search Conducted by Examiner	8/29/2006	JC			
Updated Search Conducted by Examiner	2/14/2007	JC			
STIC Search was performed by M. Mims (e.g., diffracting grating range)	02/6/2007	JC			
Updated Search Conducted by Examiner	8/22/2007	JC			
Updated Search Conducted by Examiner	3/14/2008	JC			
Updated search, Assignment data search, Inventor name search, Back/Forward search	12/10/2008	JC			

INTERFERENCE SEARCH					
Class	Subclass	Date	Examiner		

/JACOB Y CHOI/ Primary Examiner.Art Unit 2885

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